

L Number	Hits	Search Text	DB	Time stamp
3	920	thin adj film adj deposition and 427/\$.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/04 13:59
4	0	thin adj film adj deposition SAME anode adj layer same cathode adj layer	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/04 13:32
5	10	(thin adj film adj deposition and 427/\$.ccls.) AND anode adj layer and cathode adj layer	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/04 13:37
6	6	(thin adj film adj deposition and 427/\$.ccls.) AND anode adj layer and cathode adj layer AND electrolyte adj layer	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/04 13:58
7	2	(thin adj film adj deposition and 427/\$.ccls.) AND anode adj layer and cathode adj layer AND electrolyte adj layer AND seal	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/04 13:59
8	8	thin adj film adj deposition and 427/\$.ccls. AND interconnect adj layer	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/03/04 14:00
-	0	29/592.1.ccls. and thin?film same electrochemical	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/23 12:52
-	16	29/592.1.ccls. and thin?film	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/21 15:45
-	2	thin?film SAME anode adj layer SAME cathode adj layer SAME edges	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/21 15:48
-	12	thin?film SAME anode adj layer SAME cathode adj layer AND edges	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/06/21 15:48